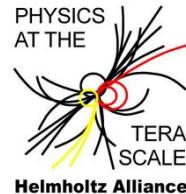




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Charge collection close to the Si-SiO₂ interface of silicon strip sensors

Thomas Pöhlsen, Eckhart Fretwurst, Robert Klanner,
Sergej Schuwalow, Jörn Schwandt, Jiaguo Zhang

University of Hamburg

Overview

Introduction

Charge collection close to the Si-SiO₂ interface

- Weighting potential
- Time resolved signals
- Integrated signals

Results: Charge losses vs. humidity and bias history

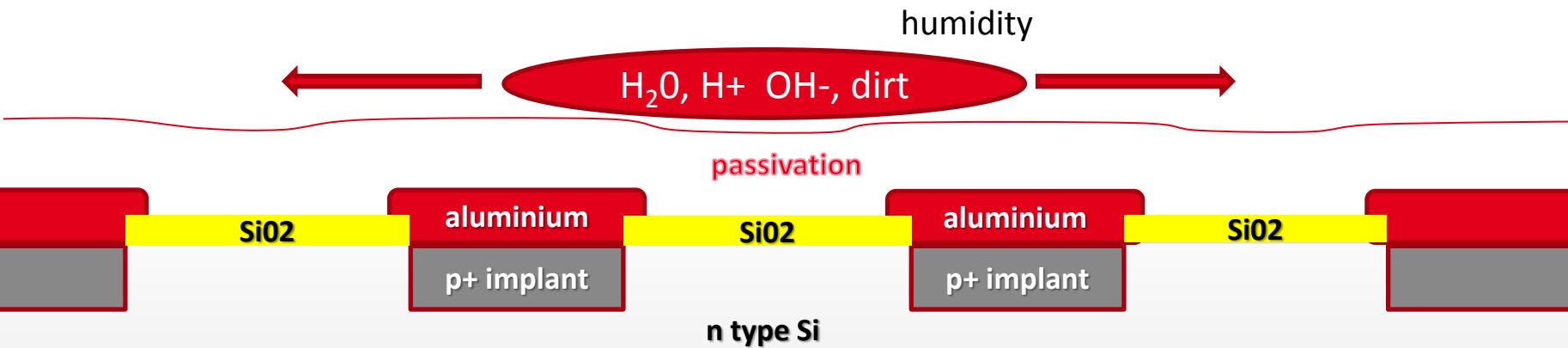
Conclusions

Outlook

Motivation – why surface studies?

Surface effects:

- Relevant for sensor stability (breakdown, stability of dark current, etc.)
- Charge carrier losses
- Humidity found to influence the electric field in sensor
- Electric field at the interface ?
(surface charges, surface potential, oxide charges, etc. => boundary conditions ?)



Sensors and irradiation

Producer	HPK	CiS
Coupling	DC	AC
Full depletion voltage	155 V	63 V
n-doping	10^{12} cm^{-3}	$8 \cdot 10^{11} \text{ cm}^{-3}$
Pitch	50 µm	80 µm
Implant width	11 µm*	20 µm
Number of strips	128	98
Strip length	8 mm	7.8 mm
Thickness	450 µm	285 µm
Orientation	<1 1 1>	<1 0 0>
SiO_2 (+ Si_3N_4)	334 nm	300+50 nm

* + 2 µm Al overhang

Irradiation:

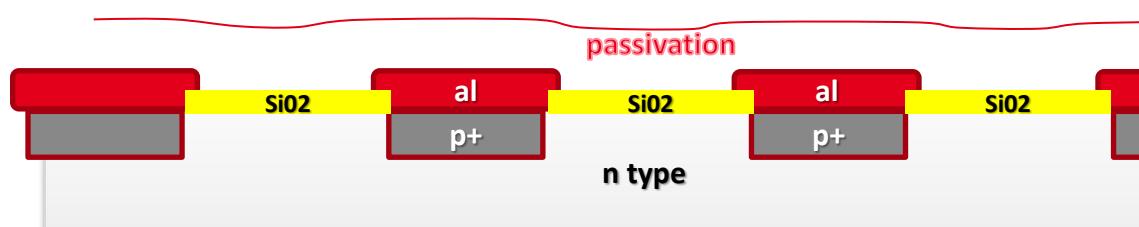
- Non-irradiated
 - Irradiated (1 MGy x-rays, 12 keV)
- ⇒ surface damage only

fixed oxide charge: $N_{\text{ox}} = \sim 2 \cdot 10^{12} \text{ cm}^{-2}$
 surface current: $I_{\text{surf}} = \sim 6 \mu\text{A cm}^{-2}$

Atmosphere during measurement:

- Humid (> 50% humidity)
- Dry (nitrogen, < 5% humidity)

T = ~24 °C (room temperature)



Measurement procedure (red laser TCT)

Red laser light (front illumination, $\lambda = 660$ nm, penetration depth $\sim 3 \mu\text{m}$)

Sub ns-pulses (FWHM 100 ps, 1 kHz, 30 000 to 500 000 eh-pairs)

Focus: $\sigma = 3 \mu\text{m}$ (+ tails)

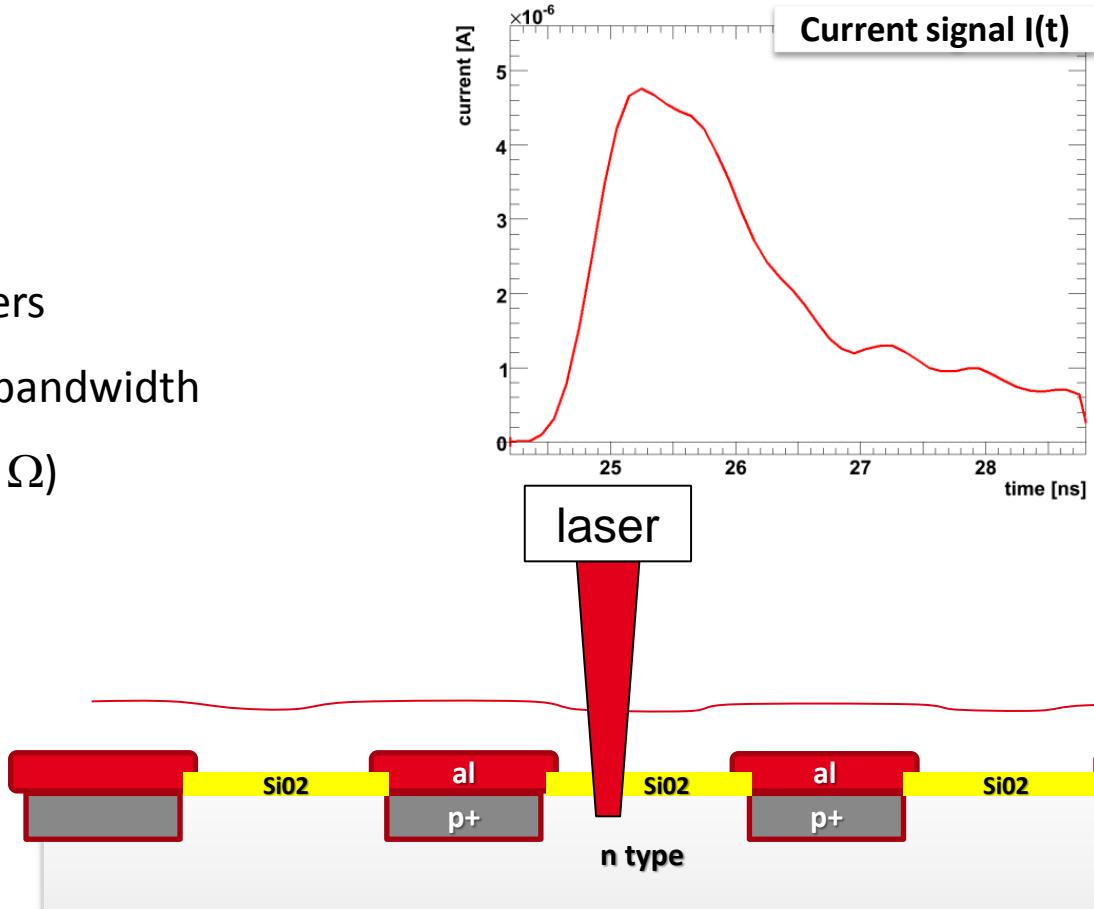
Readout: 2 strips + 1 rear contact

- Miteq AM-1309 current amplifiers
- Tektronix oscilloscope, 2.5 GHz bandwidth

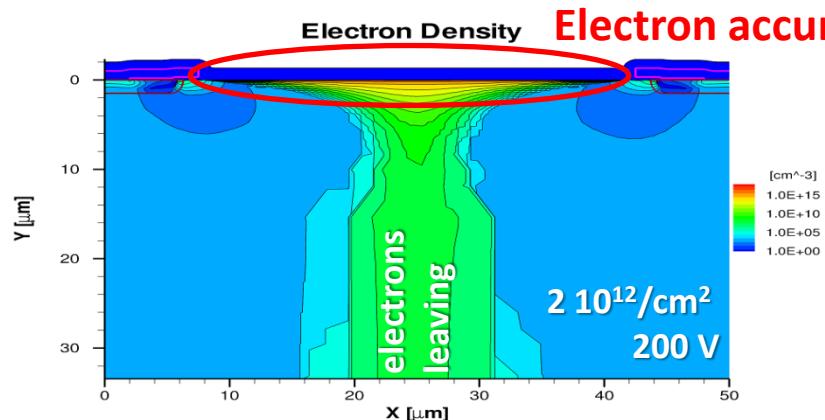
Neighbour strips on ground (via 50Ω)

Charge Q calculated offline:

$$Q = \int I(t) dt$$



Accumulation layer and electric field (simulation)



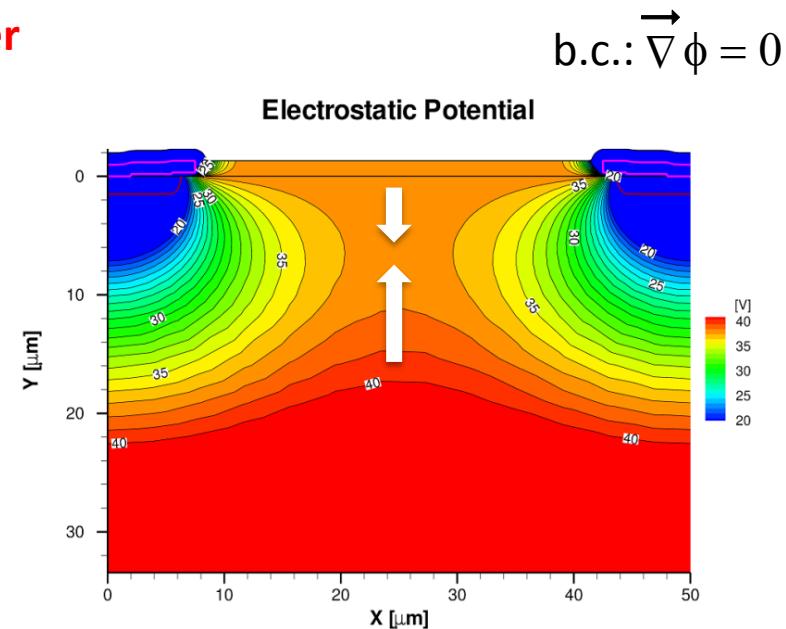
1 MGy irradiation (surface damage)

$$\Rightarrow N_{\text{ox}} = 2 \cdot 10^{12} \text{ cm}^{-2}, I_{\text{surf}} = 6.4 \mu\text{A cm}^{-2}$$

\Rightarrow Electron accumulation layer present

- \Rightarrow Influences the weighting potential $\phi_{w,j}$
- \Rightarrow Calculate $\phi_{w,j}$ under bias:

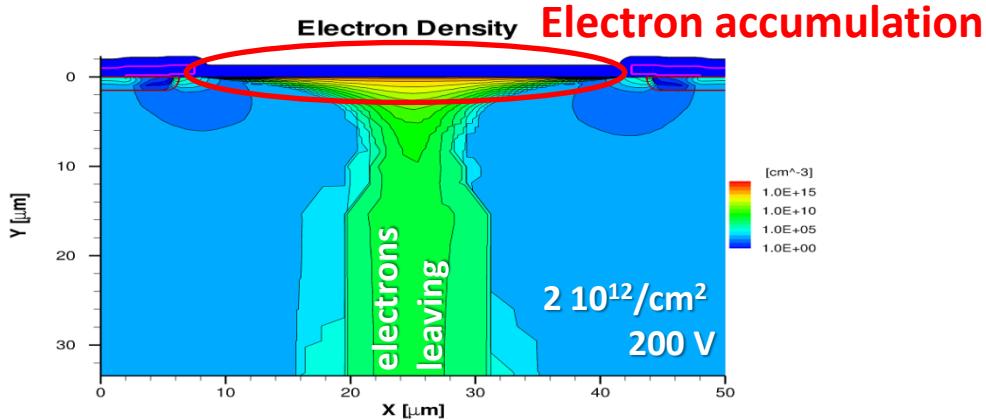
$$\phi_{w,j} = \begin{array}{l} \text{read out strip } j: 1 \text{ V} \\ \text{other strips: } 0 \text{ V} \\ \text{rear side: } 200 \text{ V} \end{array} - \begin{array}{l} \text{readout strip } j: 0 \text{ V} \\ \text{other strips: } 0 \text{ V} \\ \text{rear side: } 200 \text{ V} \end{array}$$



\Rightarrow Electron losses !

also see Hamel, Julien NIMA 597(2008), 207

Weighting potential (simulation)



1 MGy irradiation (surface damage)

$$\Rightarrow N_{\text{ox}} = 2 \cdot 10^{12} \text{ cm}^{-2}, I_{\text{surf}} = 6.4 \mu\text{A cm}^{-2}$$

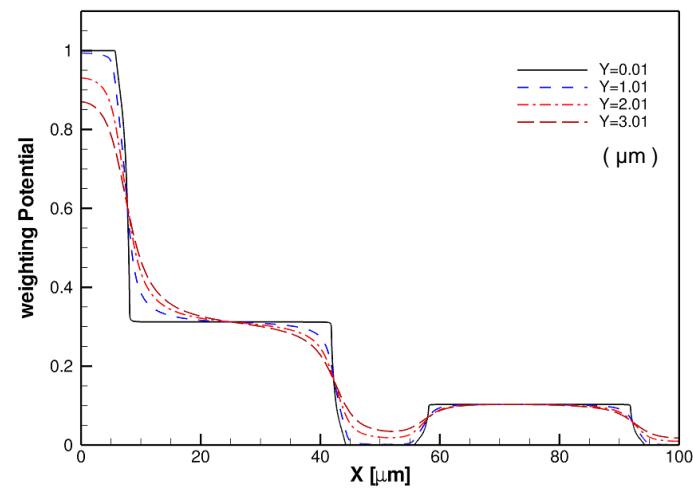
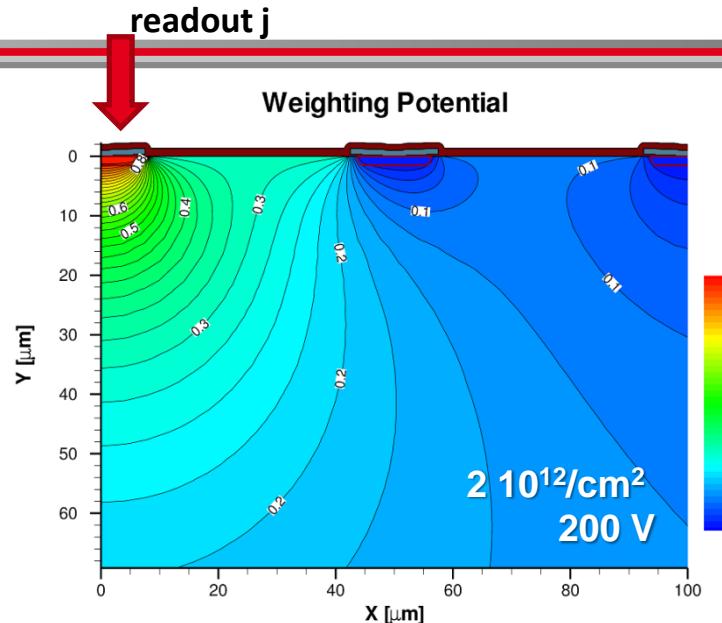
\Rightarrow Electron accumulation layer present

- \Rightarrow Influences the weighting potential $\phi_{w,j}$
- \Rightarrow Calculate $\phi_{w,j}$ under bias:

$\phi_{w,j} =$

read out strip j: 1 V
other strips: 0 V
rear side: 200 V

readout strip j: 0 V
other strips: 0 V
rear side: 200 V



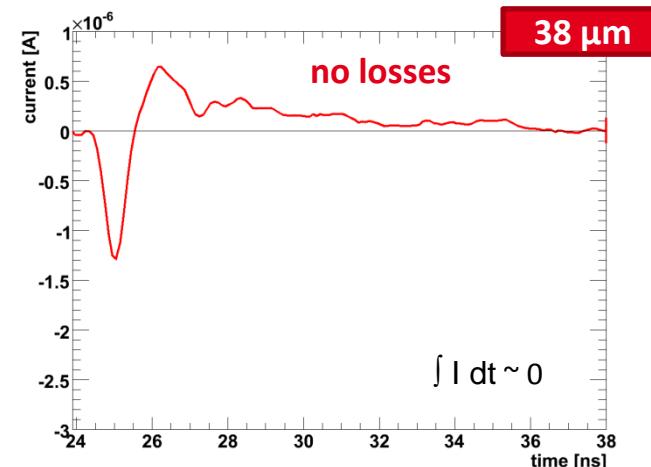
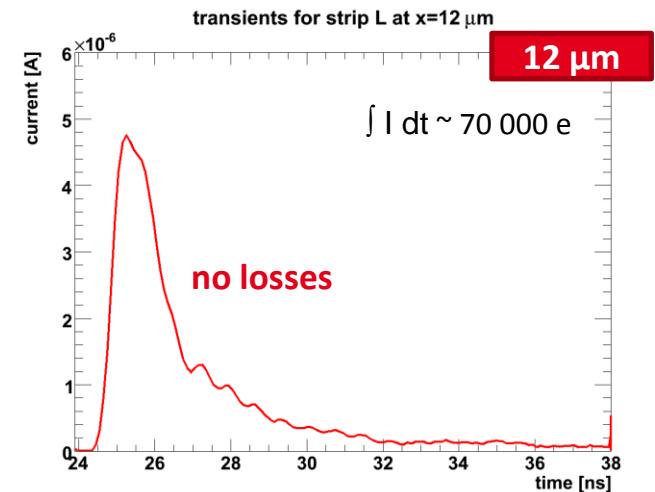
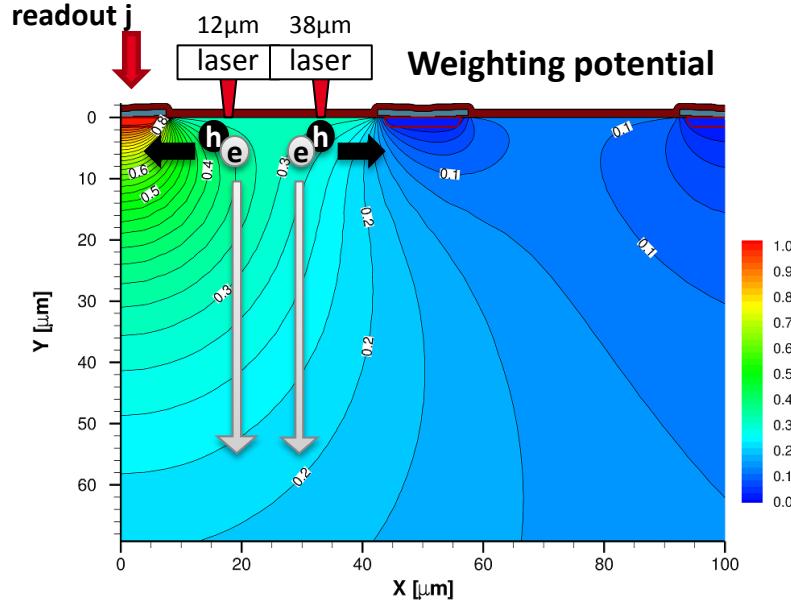
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Weighting potential and induced current

Charge carriers (q)

- drift in the electric field : $\vec{v}_{dr} = \mu \vec{E}$
- \Rightarrow Induced current: $I_j = q \vec{E}_{w,j} \cdot \vec{v}_{dr}$, $\vec{E}_{w,j} = \vec{\nabla} \phi_{w,j}$

Collected charge : $Q_j = \int I_j dt$

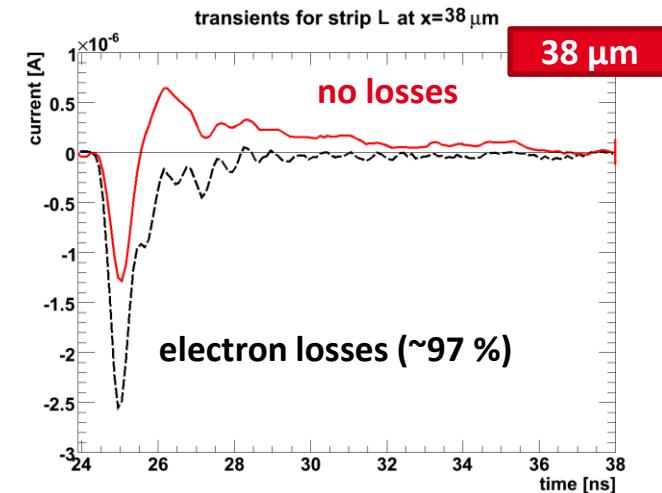
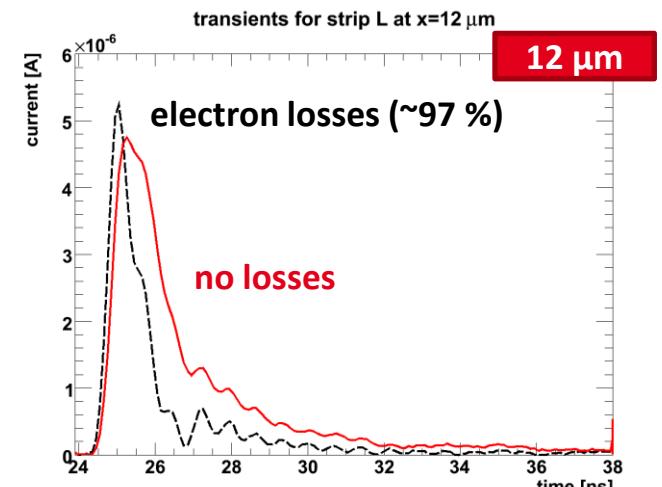
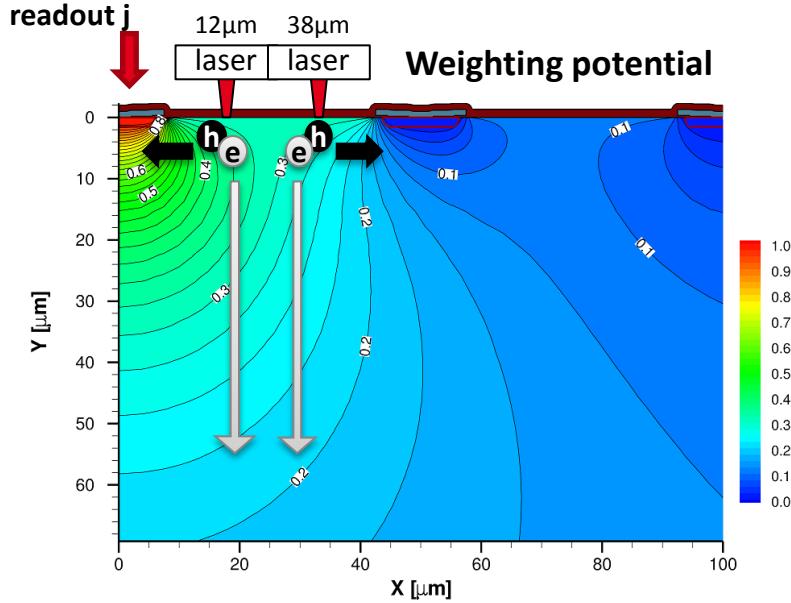


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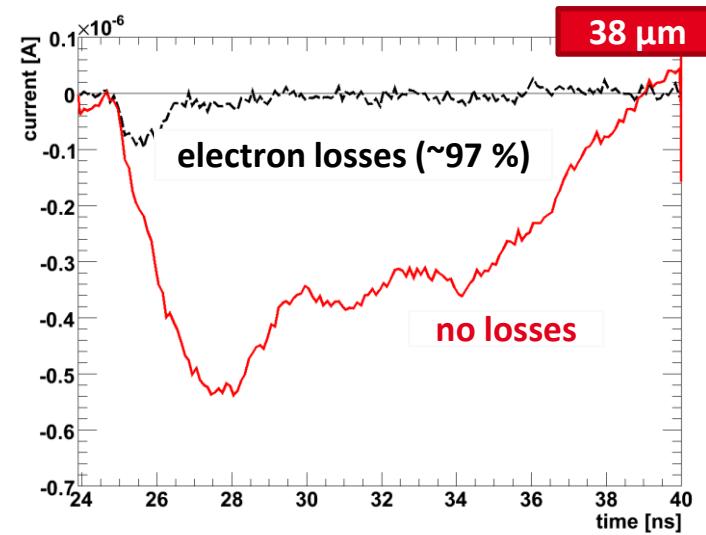
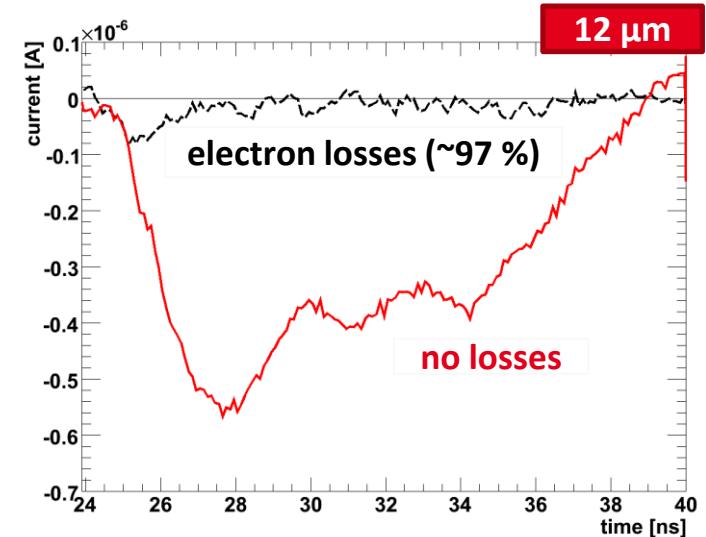
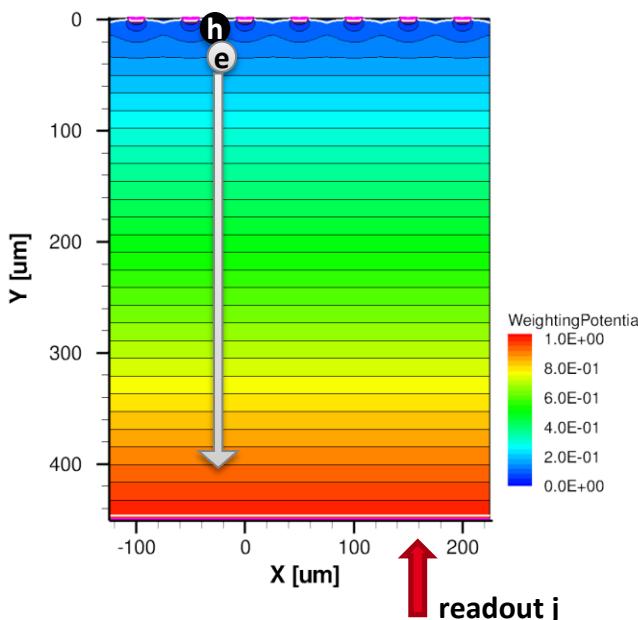
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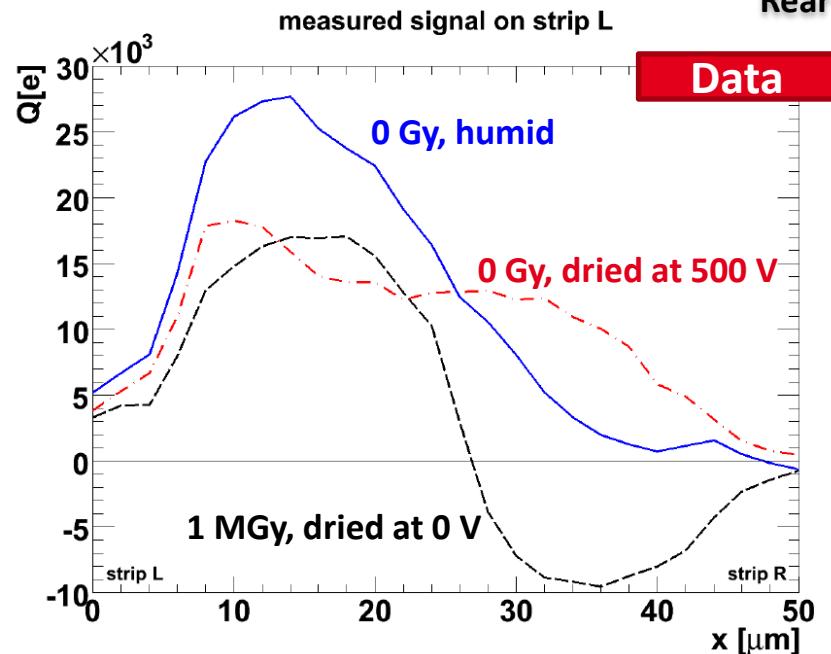
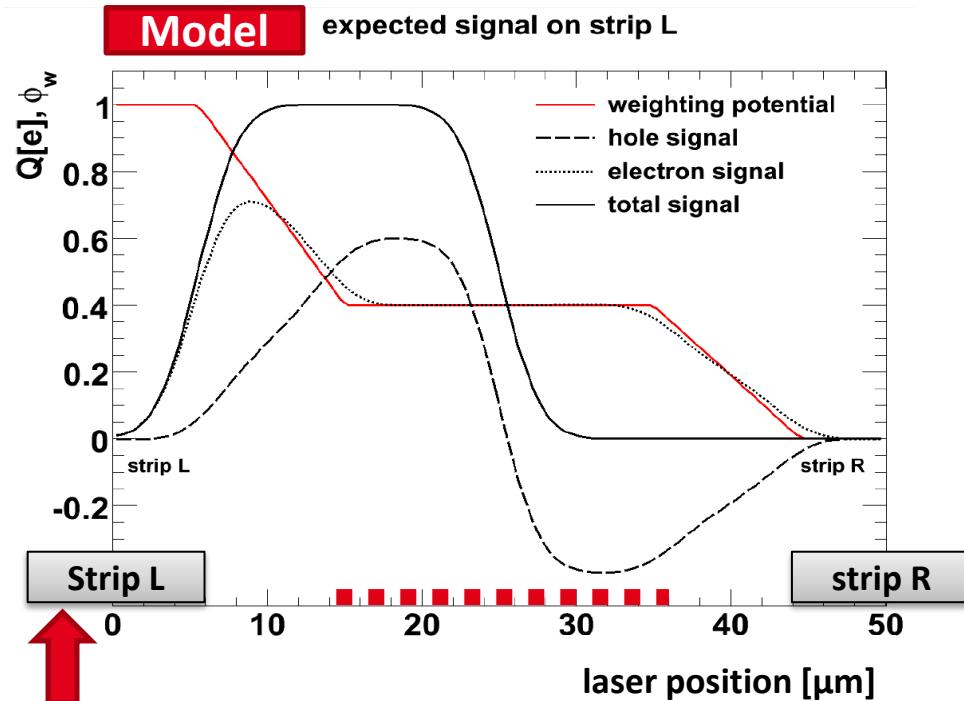
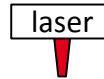
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Weighting potential, rear



Collected charge vs. laser position



Assumptions:

$\phi_w = \text{const}$ at accumulation layer, linear else

Holes: collected at closest strip

Light profile: gaussian with $\sigma=2 \mu\text{m}$

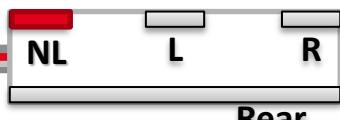
+ hole diffusion

Fit results

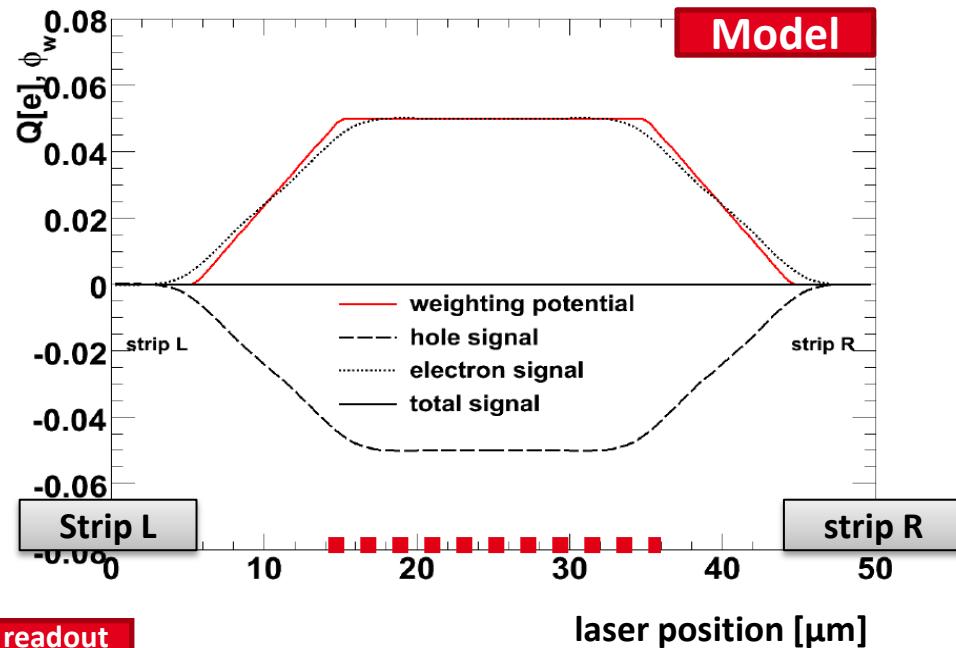
	1 MGy	dried at 500V	humid
electr.	1k	35k	33k
holes	29k	7k	31k
acc layer	38 μm	30 μm	-

Collected charge vs. laser position

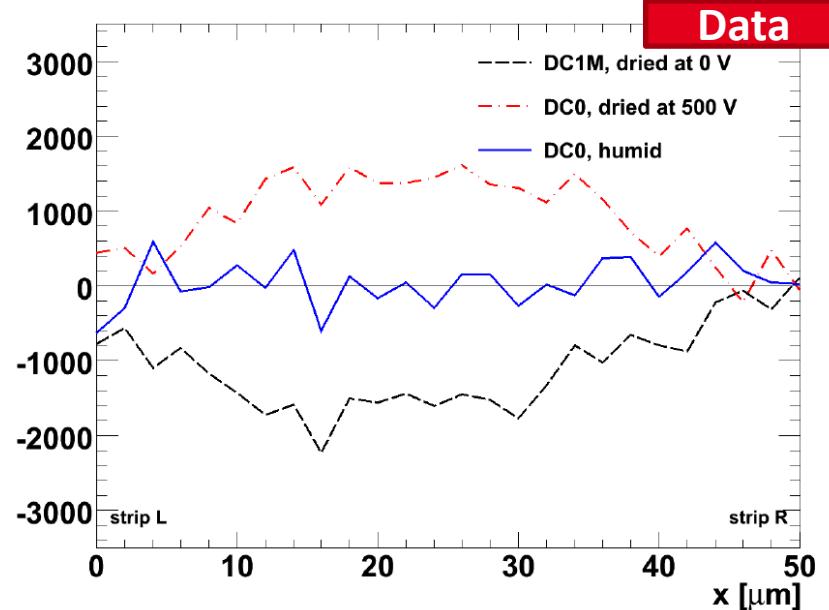
laser



expected signal on strip NL and strip NR



measured signal on strip NL



Assumptions:

$\phi_w = \text{const}$ at accumulation layer, linear else

Holes: collected at closest strip

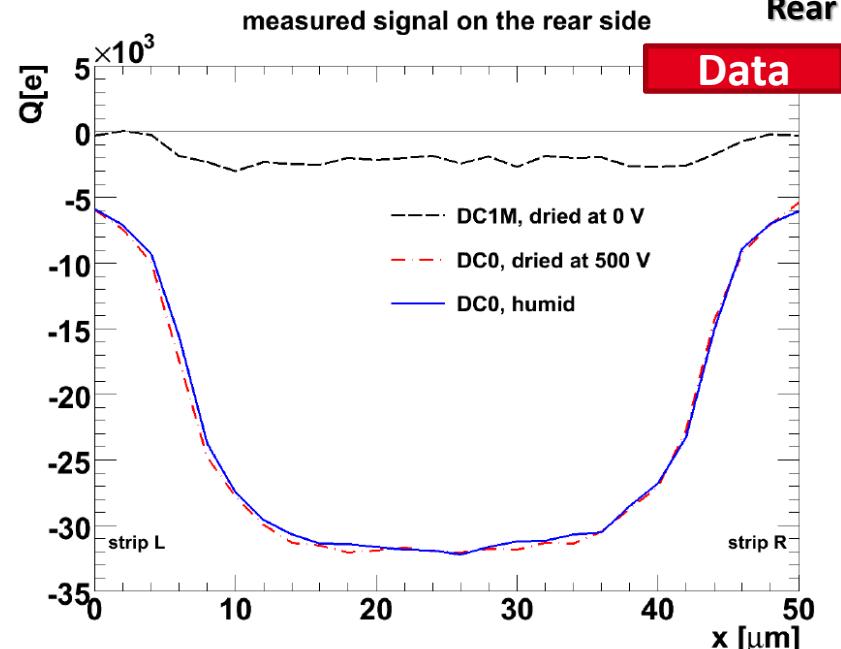
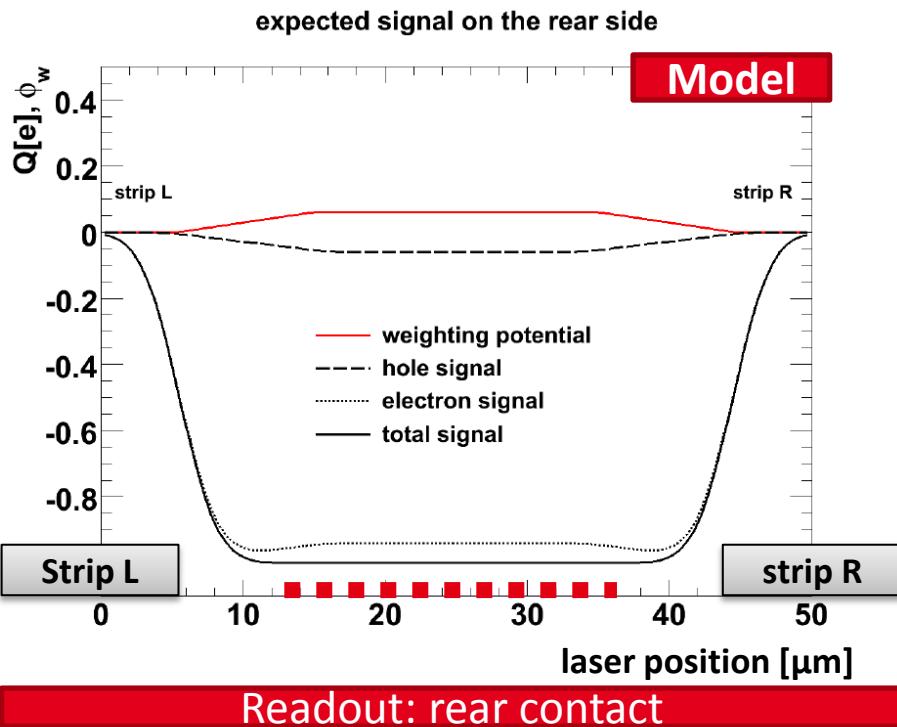
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Results on humidity and bias history

0 V steady state ⇒ 0 V dry		200 V dry			200 V humid		
		e loss	h loss	e loss	h loss		
non irradiated		40 %	0 %	0 %	0 %		
irradiated (1 MGy)		97 %	15 %	60 %	15 %		

same steady state
for all humidities
and bias histories!

500 V steady state ⇒ 500 V dry		200 V dry			200 V humid		
		e loss	h loss	e loss	h loss		
non irradiated		0 %	85 %	0 %	0 %		
irradiated (1 MGy)		20 %	15 %	60 %	15 %		

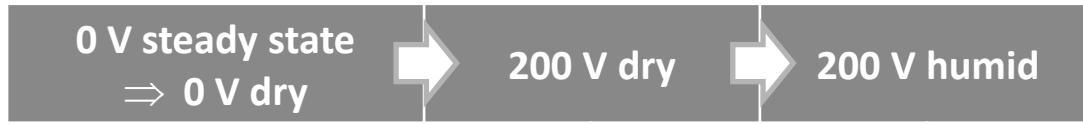
humid: steady state* reached after < 5 min

dry: steady state* reached after >> 1 hour (hours or days)

(time constants depend on many parameters)

* steady state in respect to charge loss behavior

Results on humidity and bias history



	e loss	h loss	e loss	h loss
non irradiated	40 %	0 %	0 %	0 %
irradiated (1 MGy)	97 %	15 %	60 %	15 %



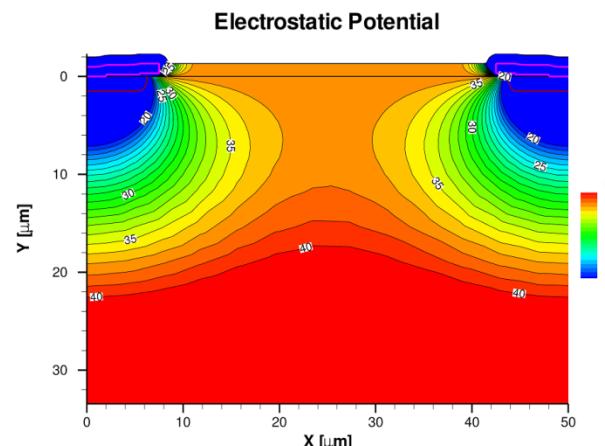
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 (time constants depend on many parameters)

same steady state
for all humidities
and bias histories!

Time dependent
surface charges ?
Dangling bonds ?



* steady state in respect to charge loss behavior

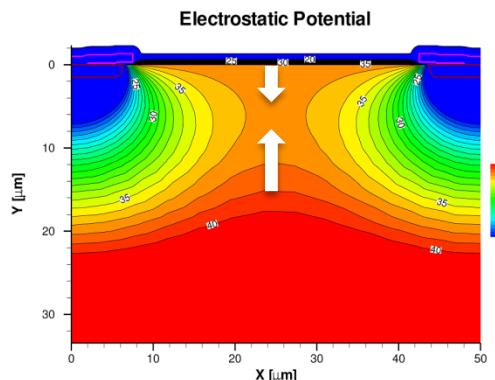
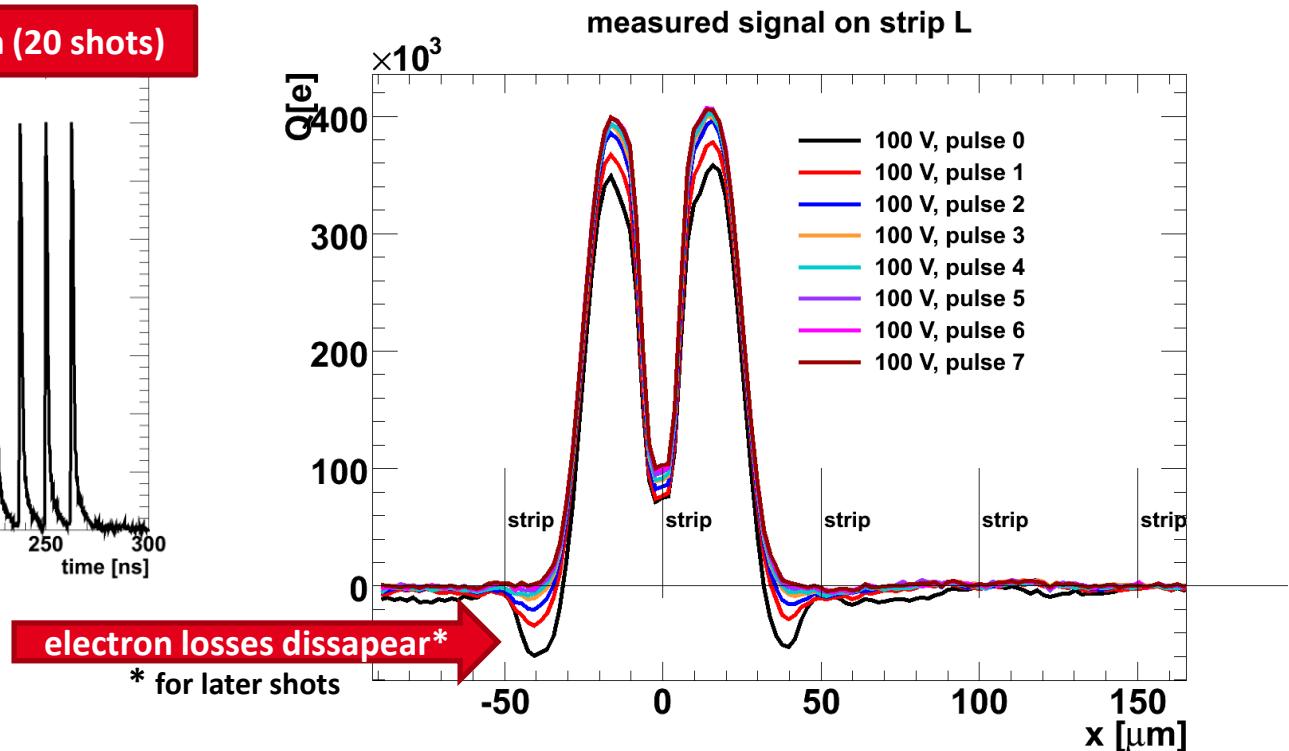
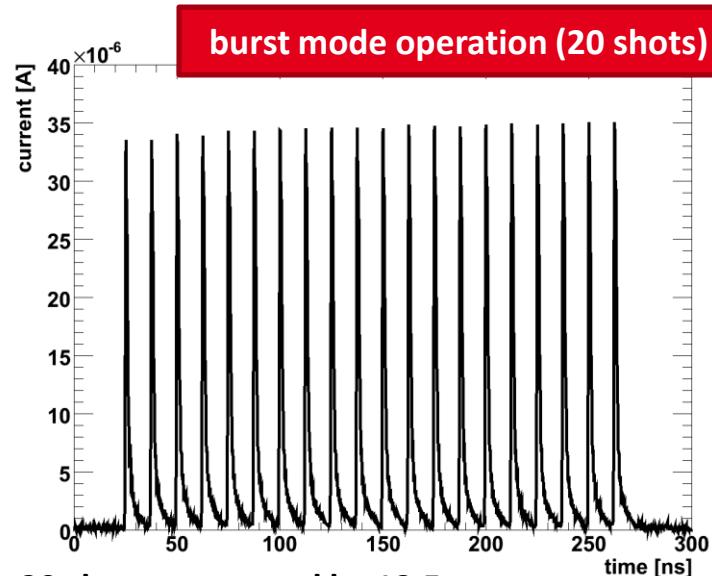
Summary and conclusions

Charge collection close to the Si-SiO₂ interface was investigated in TCT setup and described successfully by model.

Significant losses of electrons and / or holes observed.

Charge losses depend on **applied voltage, humidity, bias history** and **irradiation**.

Outlook: Saturation of electron losses



⇒ method to estimate the maximal amount of electron losses in the gap

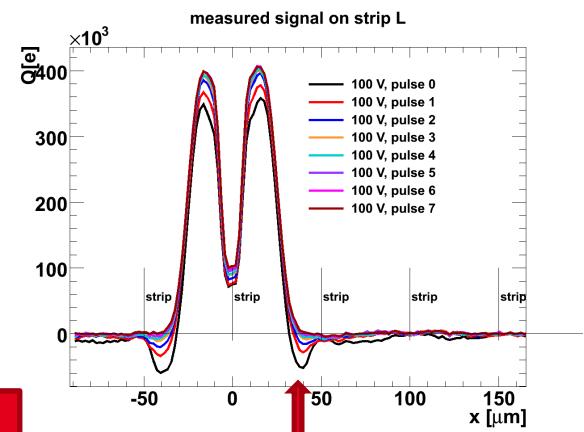
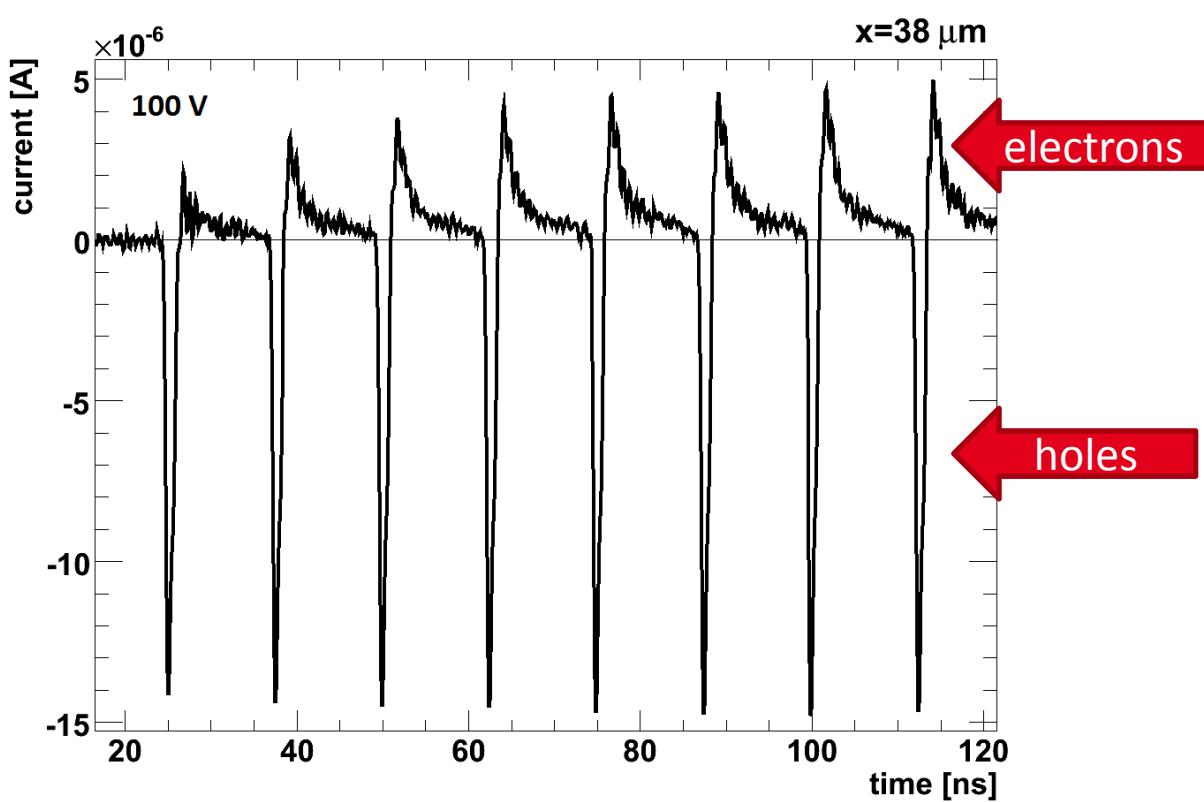
and potentially de-trapping time



Saturation of electron losses

burst mode operation (20 shots)

20 shots, separated by 12.5 ns
 1 ms later: next 20 shots



Collected charge for carrier losses

Full charge collection:

Collection: holes at strip L, electrons at rear side

$$\Rightarrow Q_L = \# \text{ holes} \cdot q_o = 3 q_o$$

$$\Rightarrow Q_{\text{rear}} = -3 q_o$$

$$\Rightarrow Q_{R,NL,NR} = 0$$

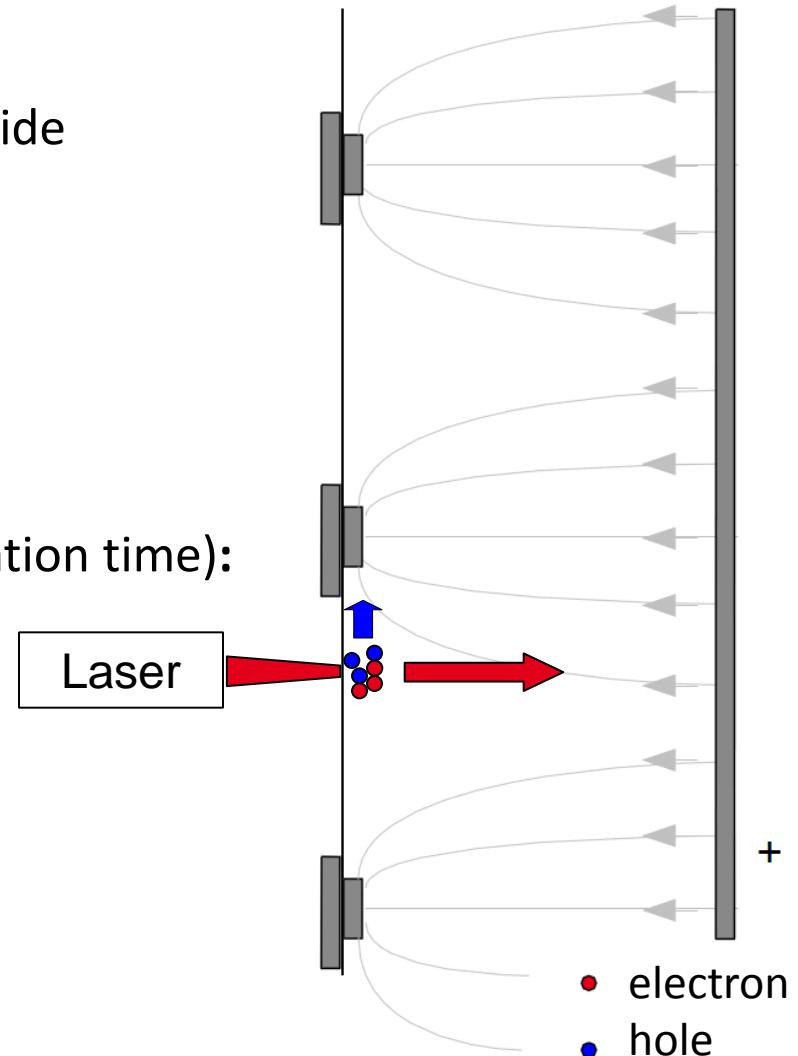
Charge losses (not collected at end of integration time):

$$\Rightarrow Q_{\text{ind},j} = \pm q \cdot \phi_{w,j} (\text{ final position })$$

$$\Rightarrow Q_L < 3$$

$$\Rightarrow |Q_{\text{rear}}| < 3$$

$$\begin{aligned} \Rightarrow Q_{R,NL,NR} &> 0 \text{ for hole losses} \\ &< 0 \text{ for electron losses} \end{aligned}$$



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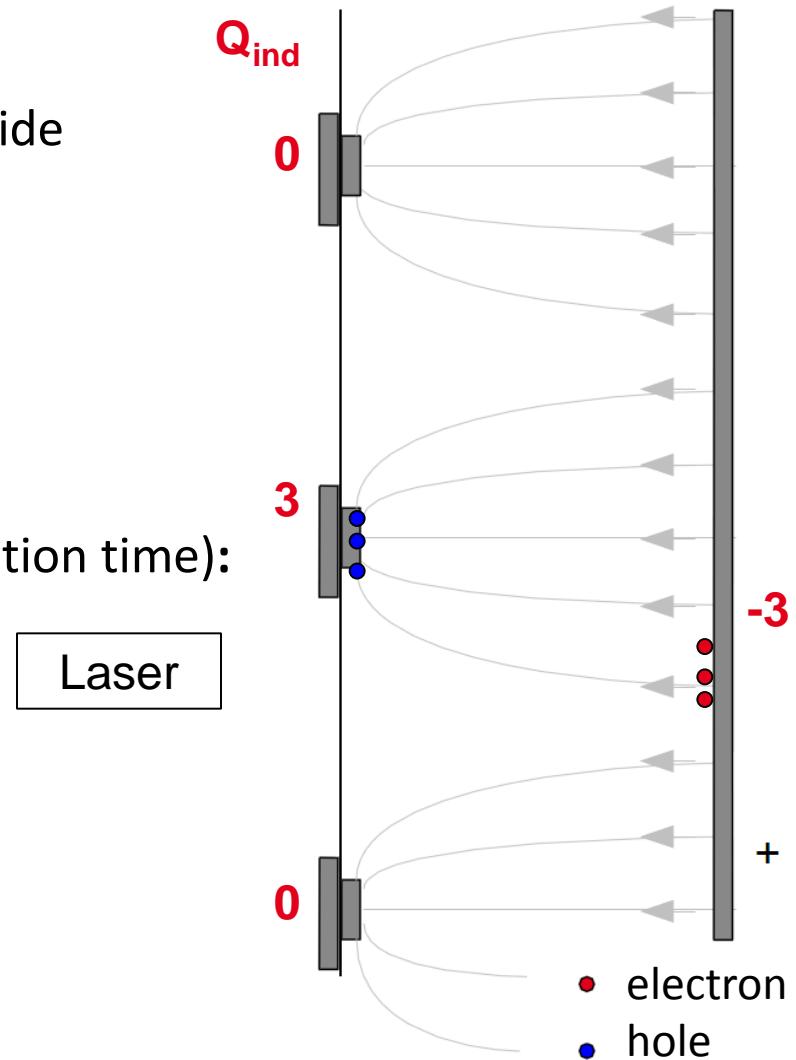
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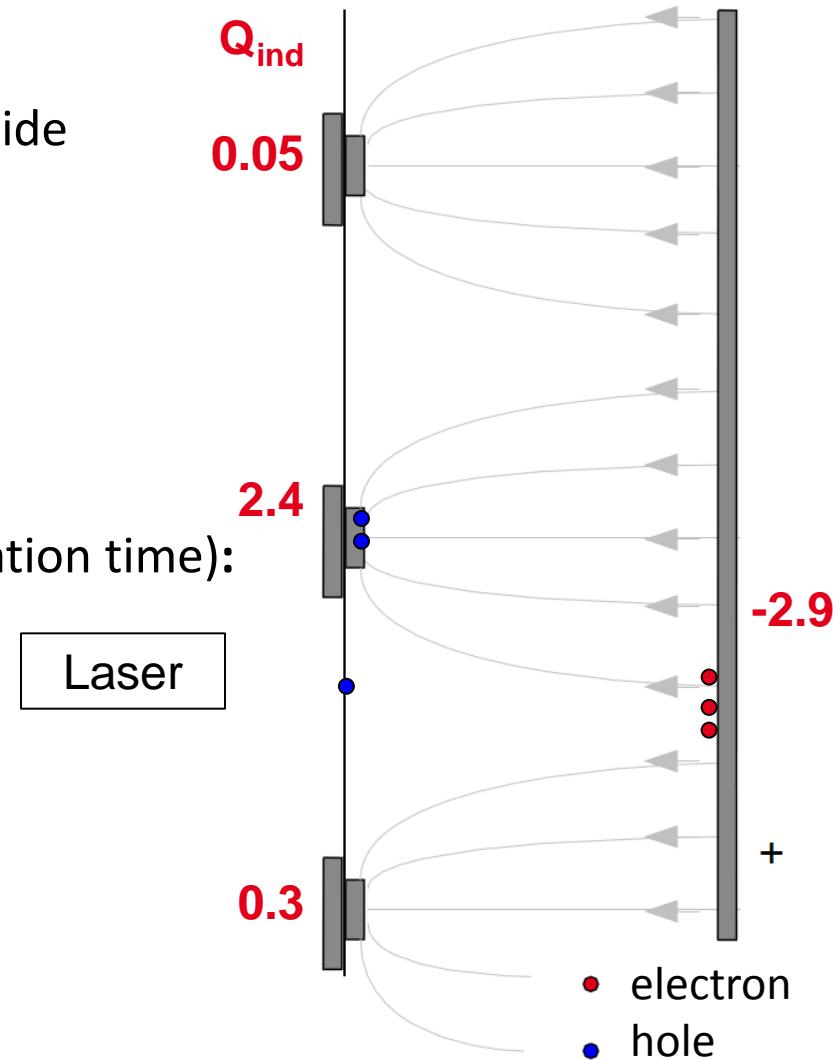
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$\Rightarrow Q_{R,NL,NR}$ **> 0 for hole losses**

< 0 for electron losses



Collected charge for carrier losses

Full charge collection:

Collection: holes at strip L, electrons at rear side

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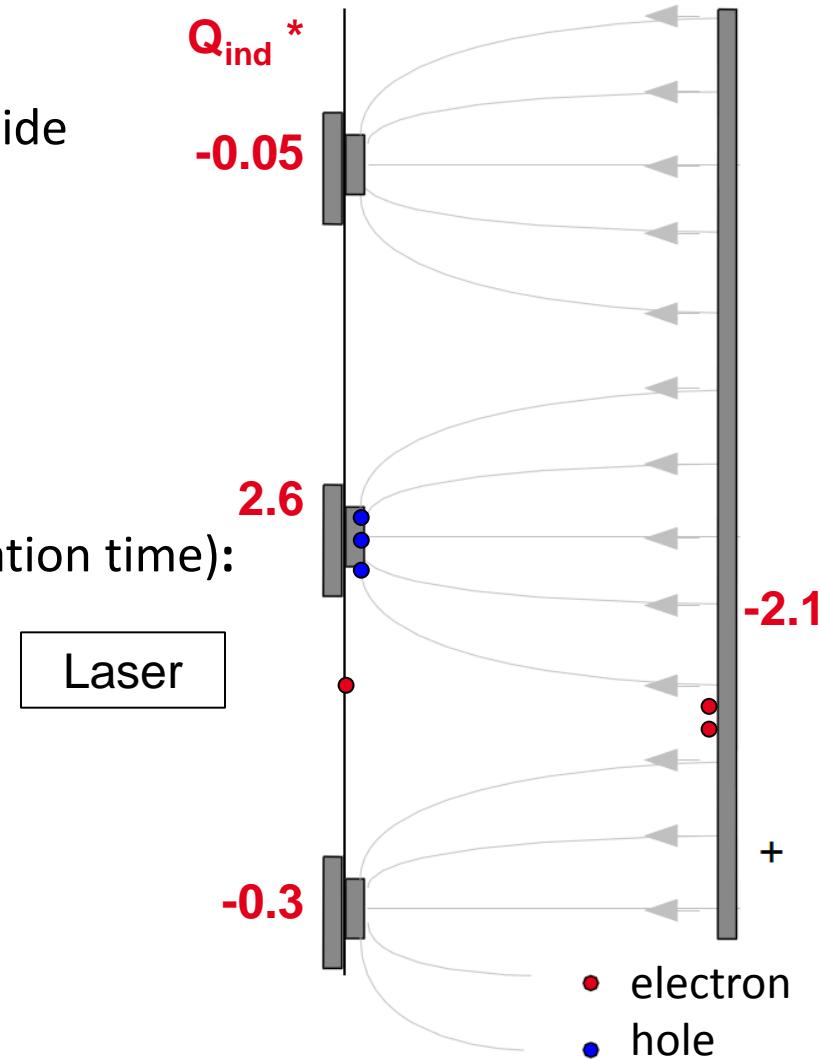
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< 0 for electron losses

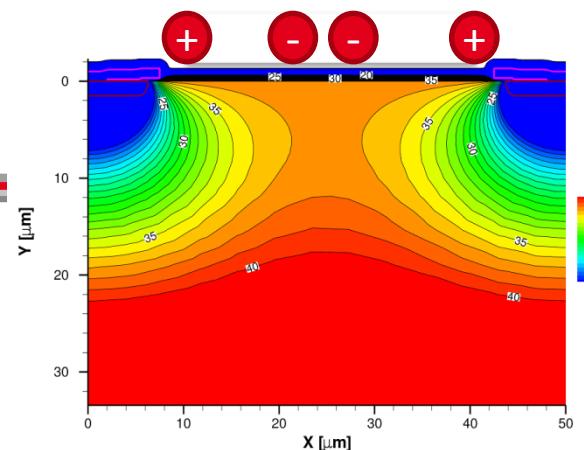


Boundary conditions

boundary conditions:

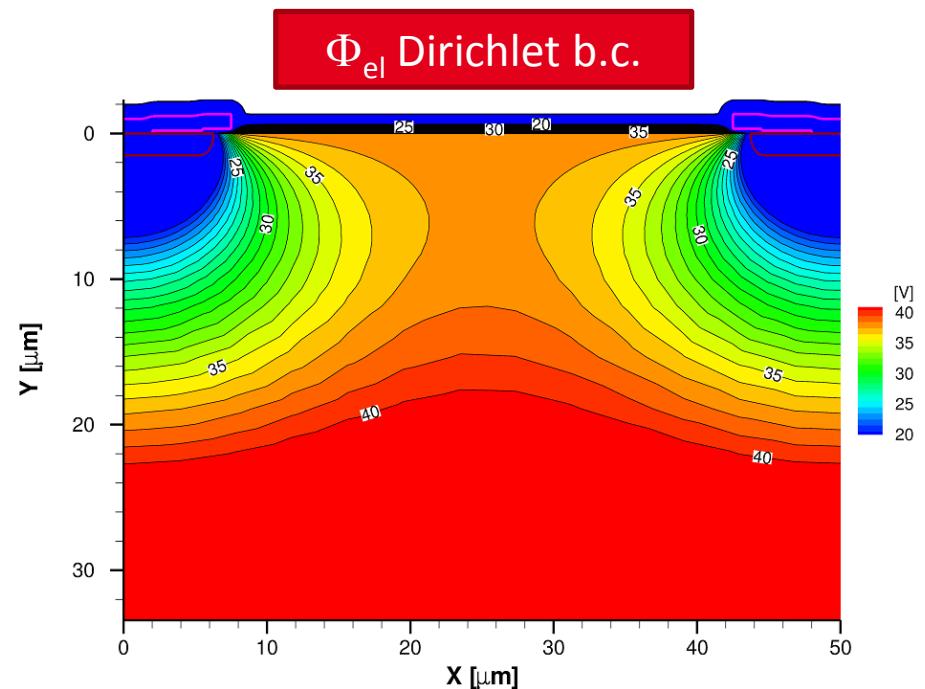
- constant potential: $\phi = 0 \text{ V}$ (Dirichlet)
- zero electric field component: $E_y = 0$ (Neumann)

~ humid ?

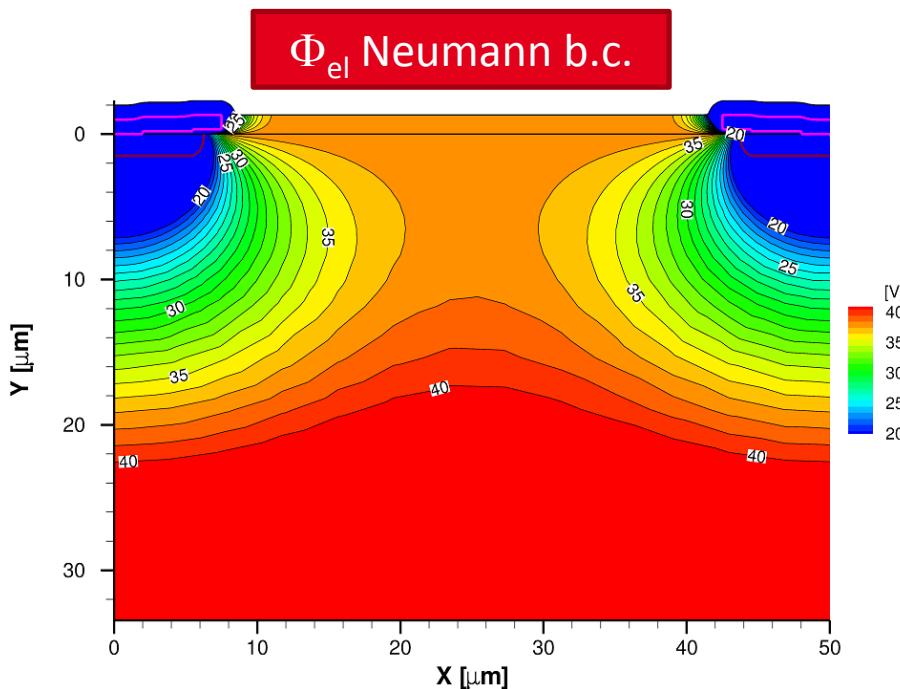


~ if dried at 0 V ?

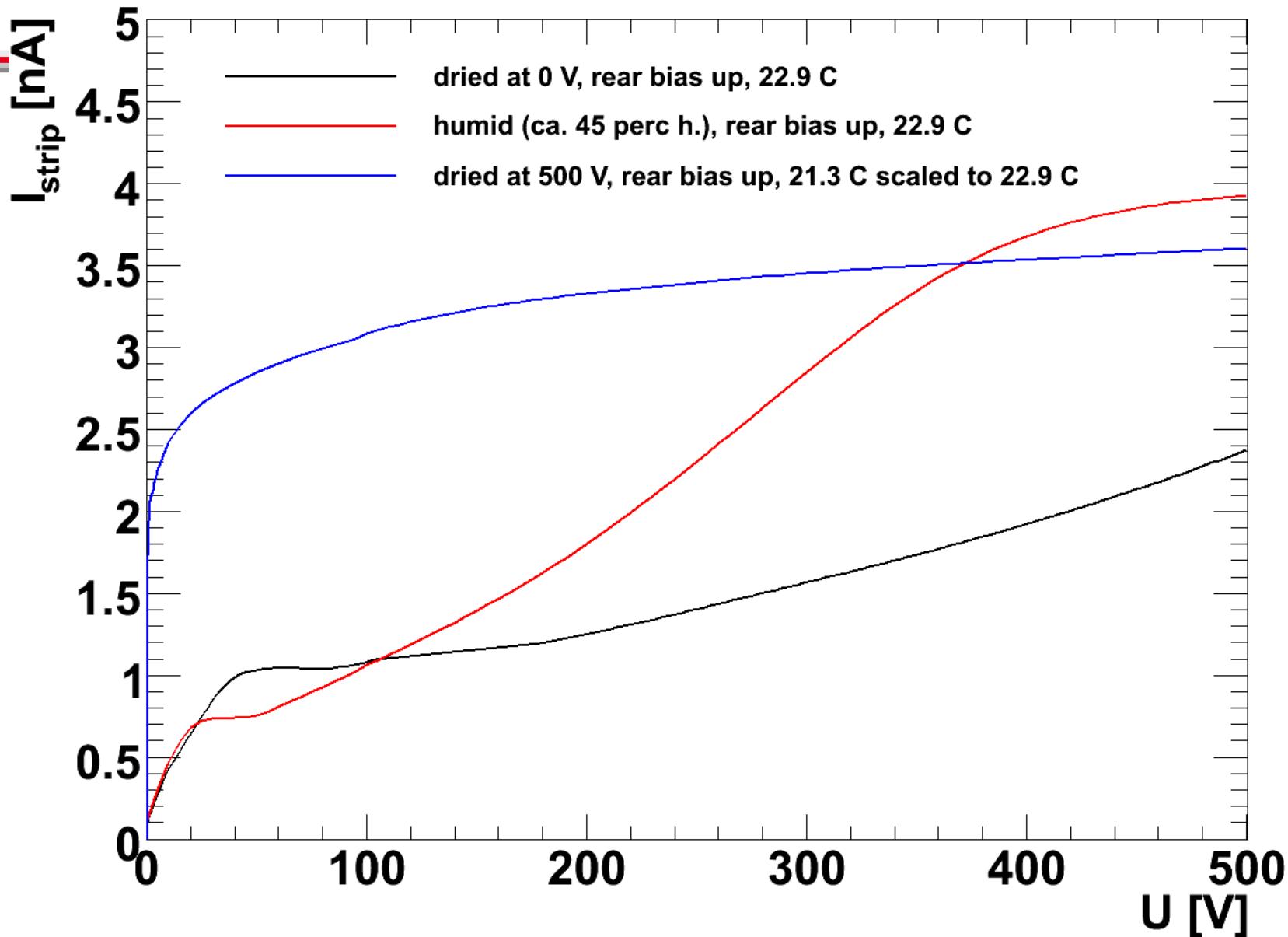
Φ_{el} Dirichlet b.c.



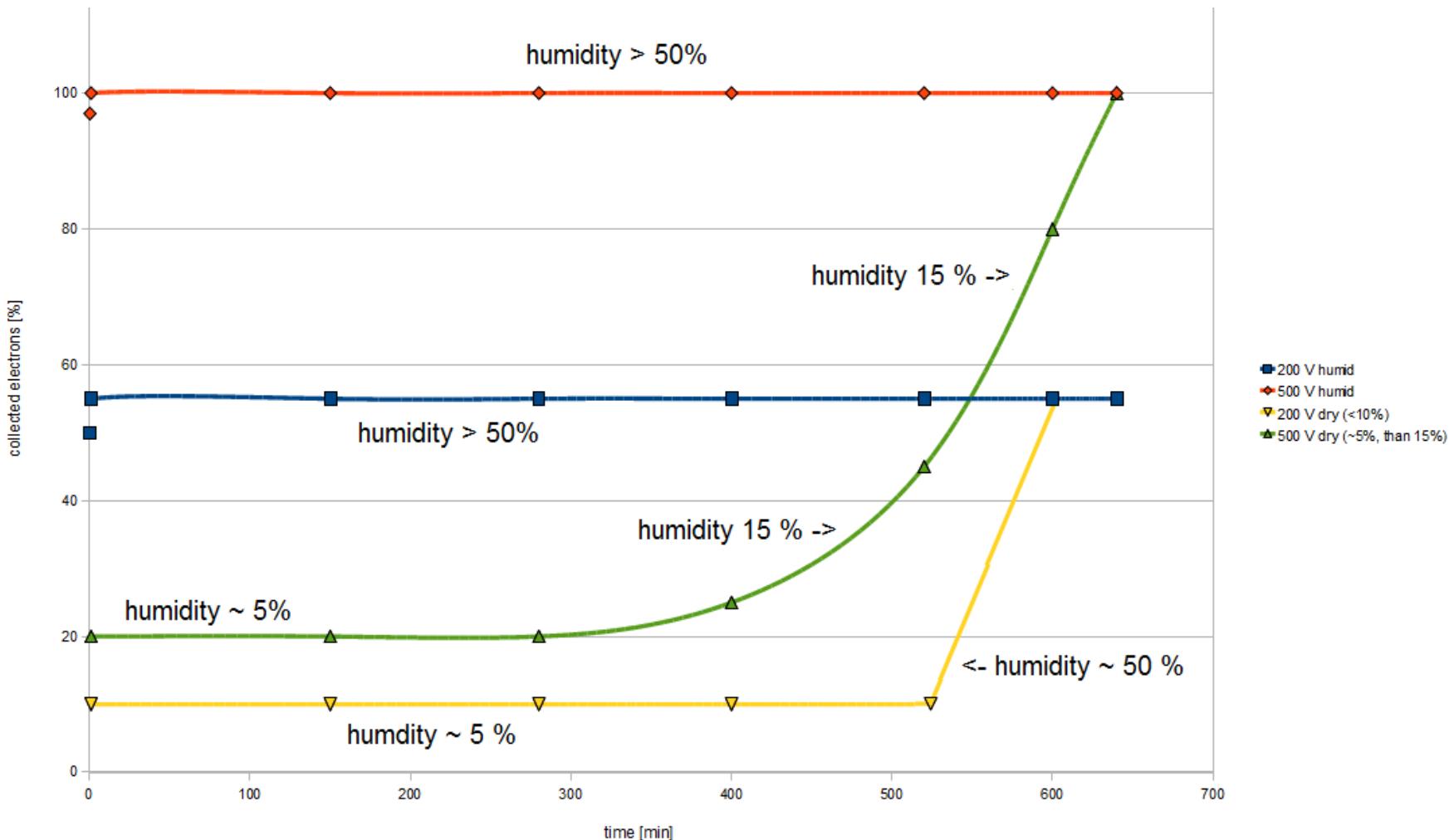
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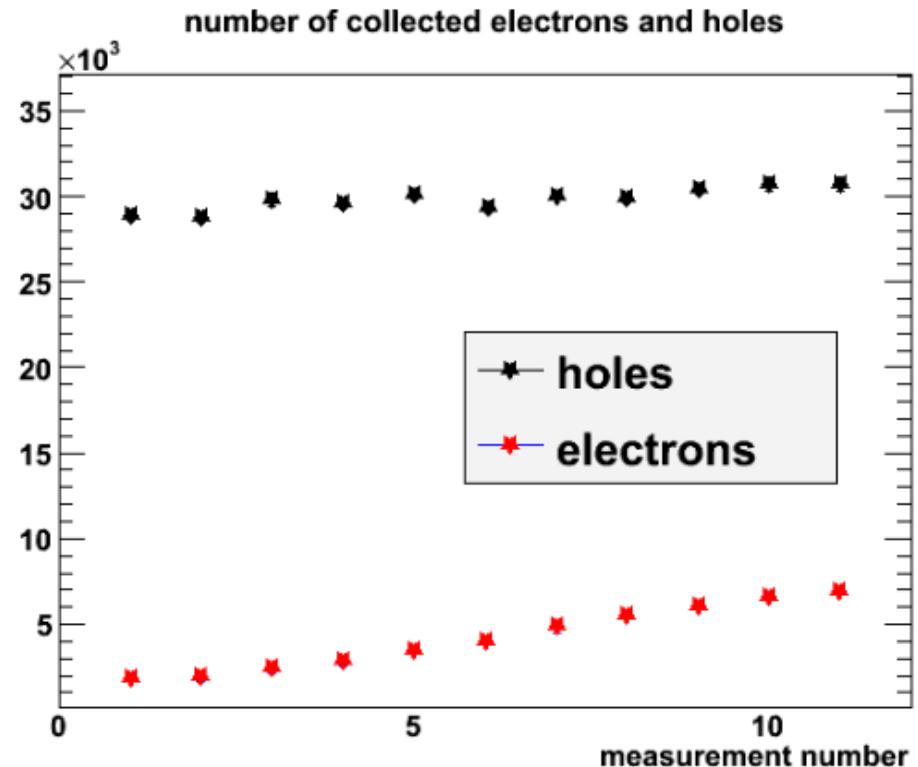
Strip current for 1 MGy



Time dependence after 1 MGy



200 V, 1 MGy, dried at 0 V



Messablauf für Elektronenverluste

Messablauf:

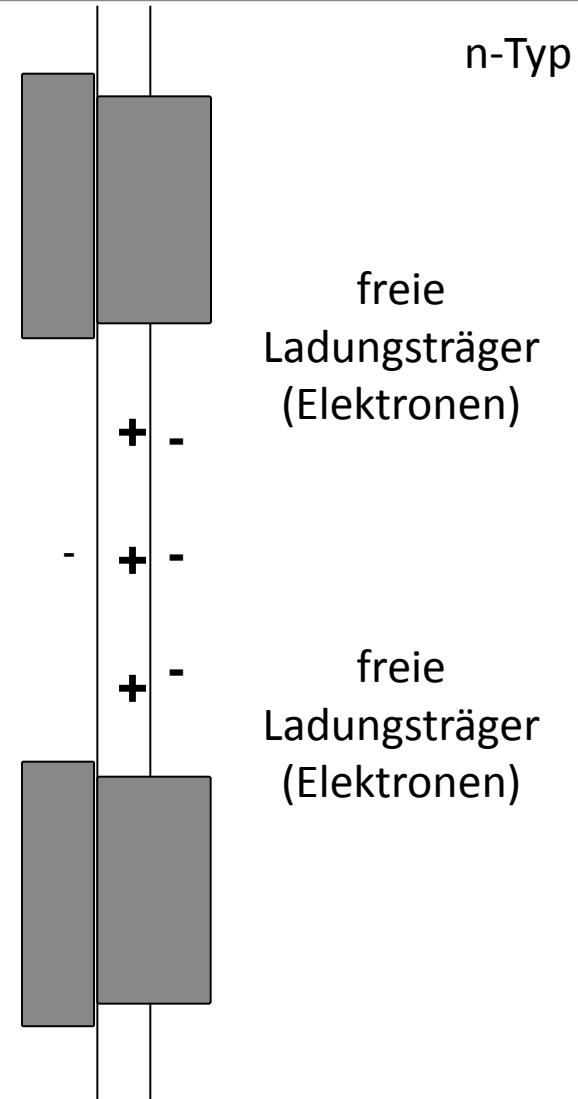
Sensor getrocknet bei 0 V

→ 200 V

Was passiert im Detektor?

0 V : Oxidladungen kompensiert durch freie Ladungsträger

200 V : Oxidladungen unzureichend kompensiert



Messablauf für Elektronenverluste

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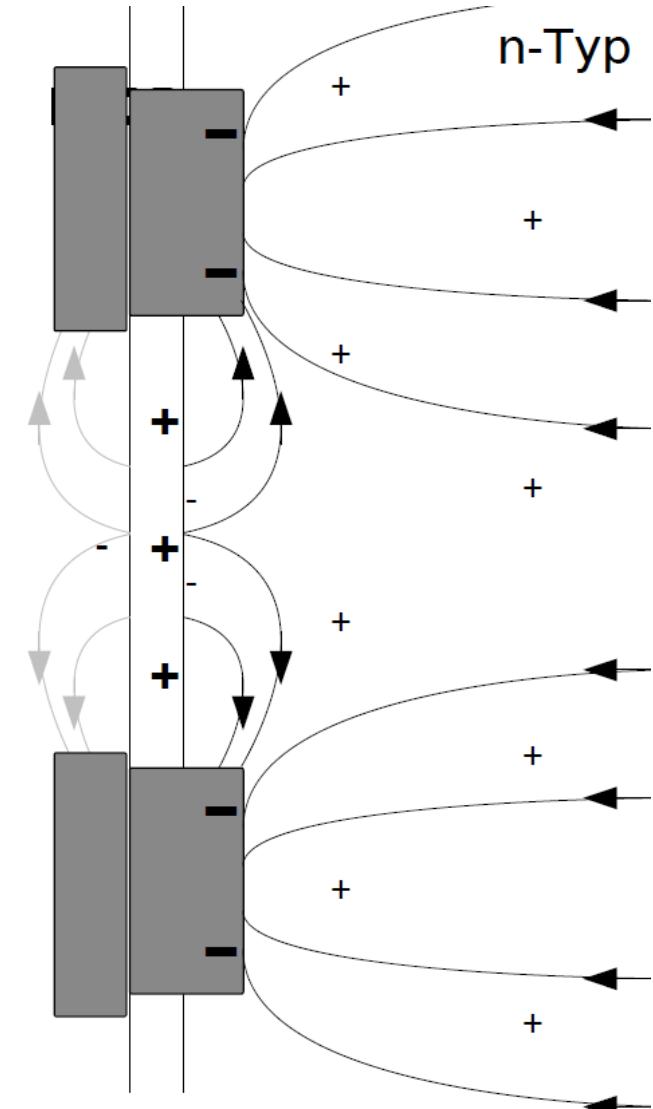
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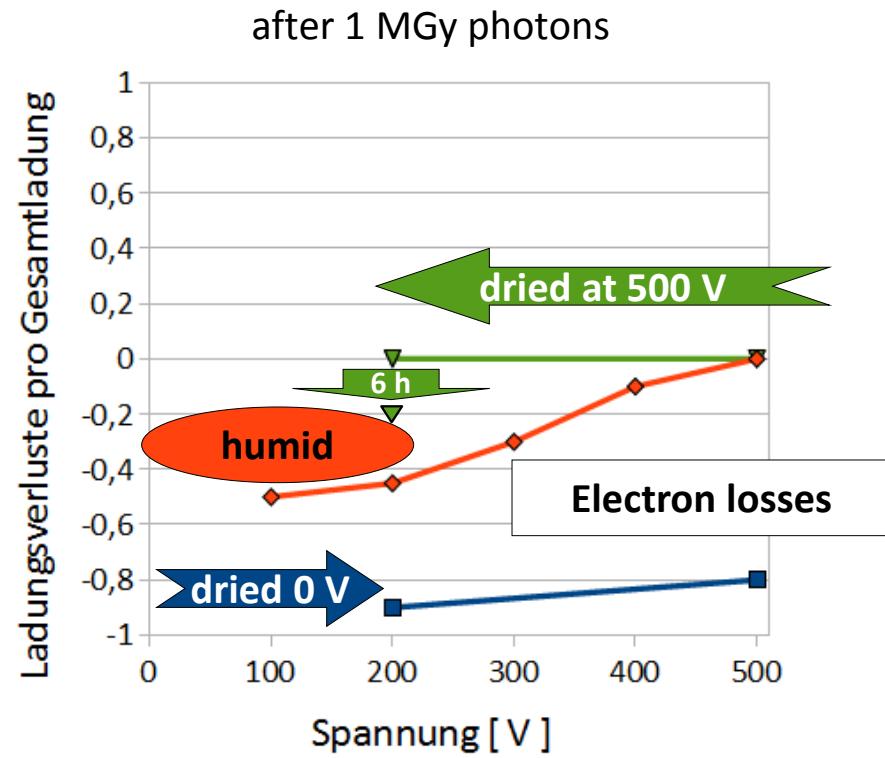
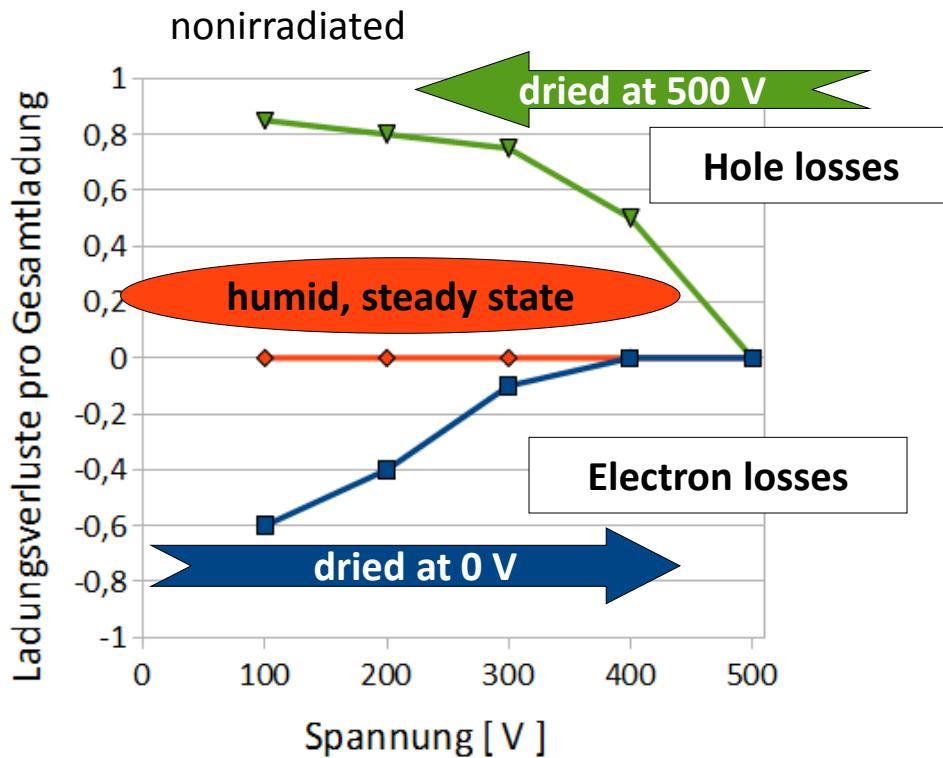
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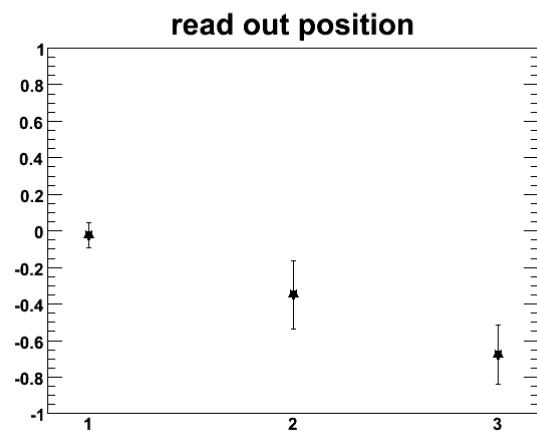
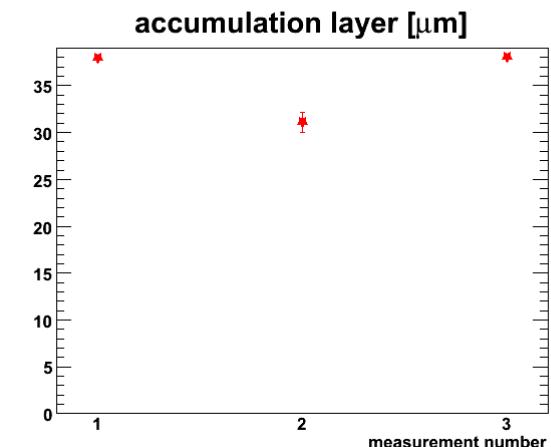
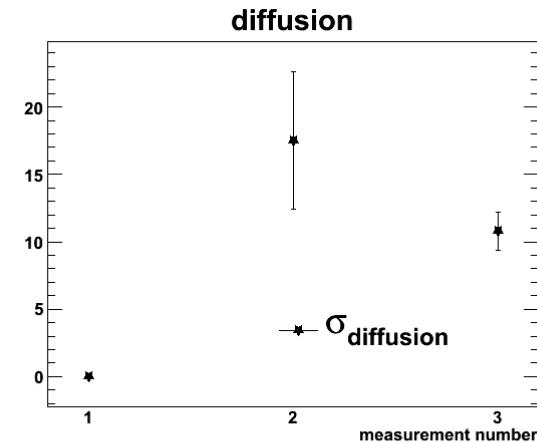
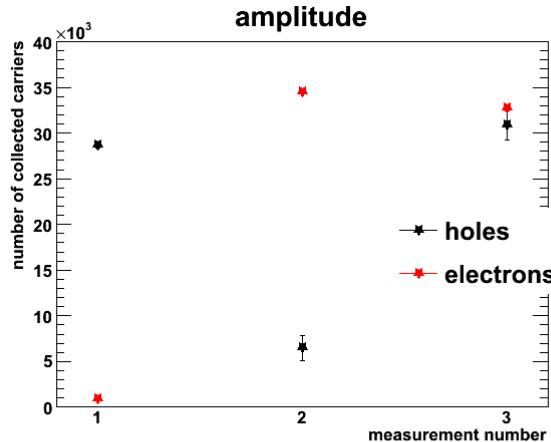


Übersicht der Ladungsverluste



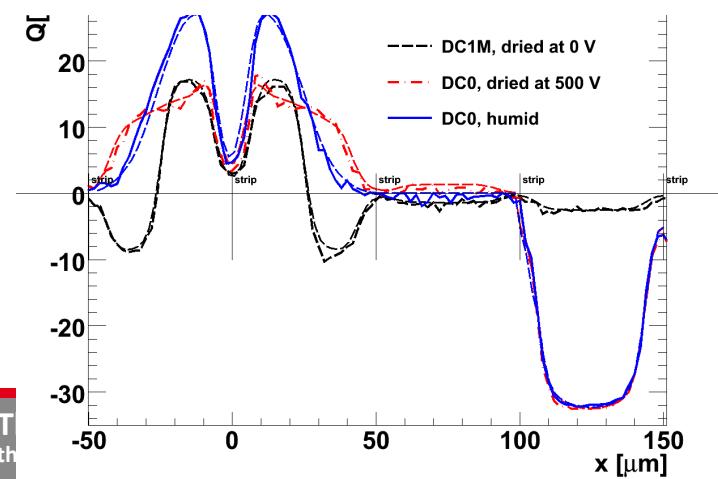
Free parameters:

- number of electrons
- number of holes
- diffusion of holes: σ_{dif}
- strip position
- accumulation layer width



Fixed parameters:

- light profile $\sigma_1=3\mu\text{m}$
+ tails $\sigma_2=9\mu\text{m}$
- $\phi_N=0.35$, $\phi_{NN}=0.05$, $\phi_{\text{rear}}=0.06$
- strip width = 12 μm



Measured signal compared to calculation

Free parameters:

- number of electrons
- number of holes
- diffusion of holes: σ_{diff}
- strip position
- accumulation layer width

Fixed parameters:

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